Lab on a Chip

CORRECTION

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Correction: Direct laser writing-enabled 3D printing strategies for microfluidic applications

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Correction for 'Direct laser writing-enabled 3D printing strategies for microfluidic applications' by Olivia M. Young *et al.*, *Lab Chip*, 2024, DOI: **https://doi.org/10.1039/D3LC00743J**.

The authors regret that the published version of Table 1 contained incorrect descriptions in the final row. The correct descriptions are shown in the updated Table 1 here.

Table 1 Summary of key characteristics of primary DLW-based strategies for fabricating 3D microfluidic technologies. Green text = advantageous capabilities; red text = disadvantageous capabilities

	In situ DLW	*Ex situ* DLW		DLW of entire microfluidic components/systems		
	Oil-immersion	DiLL	Vat	Oil-immersion	DiLL	Vat
Practical maximum print height	≤100 μm	≤12 mm	**≤40 mm**	≤100 μm	≤12 mm	**≤40 mm**
Relative range of compatible photomaterials	**High**	Low	**High**	**High**	Low	**High**
Print height-associated dosage compensation requirements	Yes	**No**	**No**	Yes	**No**	**No**
Unique print substrate-associated requirements	Thin (*e.g.*, ≤170 μm), optically transparent	**No**	**No**	Thin (*e.g.*, ≤170 μm), optically transparent	**No**	**No**
Relative DLW-associated production time	**Fast**	**Fast**	**Fast**	Slow	Slow	Slow

The Royal Society of Chemistry apologises for these errors and any consequent inconvenience to authors and readers.

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